

Title (en)

COATING LIQUID FOR FORMING SILICA-BASED FILM HAVING LOW DIELECTRIC CONSTANT AND SUBSTRATE HAVING FILM OF LOW DIELECTRIC CONSTANT COATED THEREON

Title (de)

BESCHICHTUNGSFLÜSSIGKEIT FÜR FILME AUF SILIKA-BASIS MIT NIEDRIGER DIELEKTRIZITÄTSKONSTANTE UND MIT DIESEM FILM BESCHICHTETES SUBSTRAT

Title (fr)

LIQUIDE DE REVETEMENT UTILISE POUR FORMER UN FILM A BASE DE SILICE PRESENTANT UNE FAIBLE CONSTANTE DIELECTRIQUE ET SUBSTRAT SUR LEQUEL EST COUCHE UN FILM A FAIBLE CONSTANTE DIELECTRIQUE

Publication

EP 0992556 A4 20050427 (EN)

Application

EP 99913676 A 19990415

Priority

- JP 9902017 W 19990415
- JP 11508298 A 19980424
- JP 13972398 A 19980521

Abstract (en)

[origin: EP0992556A1] The coating liquid for forming a silica-containing film with a low dielectric constant according to the present invention comprises: (i) fine particles of silica having a phenyl group thereon, and (ii) a polysiloxane obtained by reacting a hydrolyzate or hydrolyzates of an alkoxy silane represented by the formula $XnSi(OR<1>)4-n$ and/or a halogenated silane represented by the formula $XnSiX'4-n$ with a polysilazane represented by the formula: <CHEM> Further, the coating liquid for forming a silica-containing film with a low dielectric constant according to the present invention comprises: (i) fine particles of silica having a phenyl group thereon, and (ii') an oxidatively decomposable resin, the weight ratio of the fine particles of silica having a phenyl group to the oxidatively decomposable resin being in the range of 0.5 to 5. By virtue of the present invention, there can be formed a stable silica-containing film, which has a dielectric constant as low as 3 or less, which is excellent in microphotolithography workability, adherence to a substrate surface, chemical resistance such as alkali resistance and crack resistance, and which exhibits excellent planarizing performance.

IPC 1-7

C09D 183/14; C09D 201/00; C09D 5/24; C08G 77/452; C09D 183/10; H01L 21/312

IPC 8 full level

C09D 7/62 (2018.01); C09D 183/14 (2006.01); G03F 7/09 (2006.01)

CPC (source: EP KR US)

**B05D 3/06 (2013.01 - KR); C09D 7/62 (2017.12 - EP US); C09D 7/67 (2017.12 - EP US); C09D 183/04 (2013.01 - KR);
C09D 183/14 (2013.01 - EP US); G03F 7/093 (2013.01 - EP US); C08K 3/34 (2013.01 - EP US); C08K 9/04 (2013.01 - EP US);
Y10T 428/249969 (2015.04 - EP US); Y10T 428/24999 (2015.04 - EP US); Y10T 428/2962 (2015.01 - EP US);
Y10T 428/31507 (2015.04 - EP US); Y10T 428/31663 (2015.04 - EP US)**

Citation (search report)

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Designated contracting state (EPC)

DE GB NL

DOCDB simple family (publication)

**EP 0992556 A1 20000412; EP 0992556 A4 20050427; EP 0992556 B1 20120509; EP 1790703 A2 20070530; EP 1790703 A3 20090812;
EP 1790703 A8 20100630; EP 1790703 B1 20140730; KR 100600630 B1 20060713; KR 100600631 B1 20060713;
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DOCDB simple family (application)

**EP 99913676 A 19990415; EP 07002273 A 19990415; JP 9902017 W 19990415; KR 19997012205 A 19991223; KR 20067009944 A 20060522;
TW 88106468 A 19990423; US 44668699 A 19991223**